

IDW '19 1440

Type B: ITO/ZnO (NP)-HW (40 nm, Brunel) washed with hexane/ Red-CdSe/ZnSe/ZnS (25 nm) /TCTA (10 nm)/ HTL (α -NPB or HTM-14)/HATCN (10 nm)/Al

Type C: ITO/ZnO (NP)(40 nm, Brunel)/Red-InP/ZnS (20 nm) cast from hexane/TCTA/HTL(α -NPB or HTM-14) /HAT-CN (10 nm)/Al

Type D: ITO/ZnO-NP-HW (40 nm, Brunel)/Red-InP /ZnS (20 nm) cast from Octane solution/TCTA/HTL(α -NPB or HTM-14)/HAT-CN (10 nm)/Al

Type E: ITO/ZnO-NP-HW (40 nm, Brunel)-Washed with hexane/Red-InP/ZnS (20 nm) cast from Octane solution /TCTA/HTL(α -NPB or HTM-14)/HAT-CN (10 nm)/Al

The ZnO-NP (Sol-Gel) films (spin coated 3000 rpm) were annealed either at 120 °C in vacuum for 30 minutes or annealed in air at 220 °C in the furnace. All other layers including TCTA, α -NPB and HTM -14 (supplied by Merck) were evaporated (1 Å s^{-1}) and HATCN (evaporated at 0.5 Å s^{-1}) in an ULVAC OLED plant (Solciet, purchased from ULVAC, Japan) onto a patterned ITO/glass (100 mm x 100 mm) under a vacuum of 10^{-5} Torr. Deposition of the cathode also took place under vacuum ahead of device encapsulation in a nitrogen-filled glove box. QD films were dried at 80 °C in a vacuum oven for 10 minutes.

3 RESULTS & DISCUSSION

The average particle size of $7.6 \pm 1.7 \text{ nm}$ (Red CdSe/ZnSe /ZnS QD) and $8 \pm 1 \text{ nm}$ InP/ZnS (Red) and $6 \pm 1 \text{ nm}$ were obtained by TEM (Figure 3).

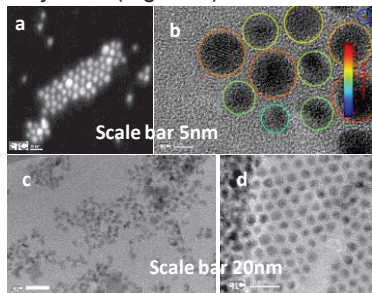


Figure. 3 a and b TEM- (CdSe/ZnSe/ZnS) . Fig. 3 (c)- Red InP/ZnS & Fig. 3 (d). Green InP/ZnS.

Figure 4 shows the absorption and the emission spectra of the red CdSe/ZnSe/ZnS and compared with red InP/ZnSe.

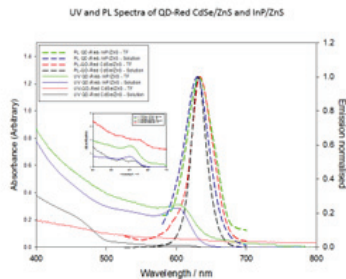


Figure. 4 Absorption and Emission Spectra of CdSe /ZnSe/ZnS and InP/ZnS in solution and thin films

The AFM images (**Figure 5**) shows the ZnO-NP film annealed at 120 °C for 30 minutes (**Figure 5 A**), ZnO-NP-HW annealed at 120 °C for 30 minutes and then washed (treated) with hexane and then annealed at 80 °C for 30 minutes (**Figure 5B**), ZnO-NP + QD (**Figure 5 C**) and ZnO-NP (HW) +QD (**Figure 5 D**). The hexane causes the ZnO-NP surface to become rougher (R_a increasing from 1.16 nm to 1.85 nm). On depositing the QD onto ZnO-NP, R_a further increases to 2.90 nm and QD on ZnO-NP-HW, R_a reduces to 1.95 nm which is only marginally higher than the R_a of ZnO-NP-HW.

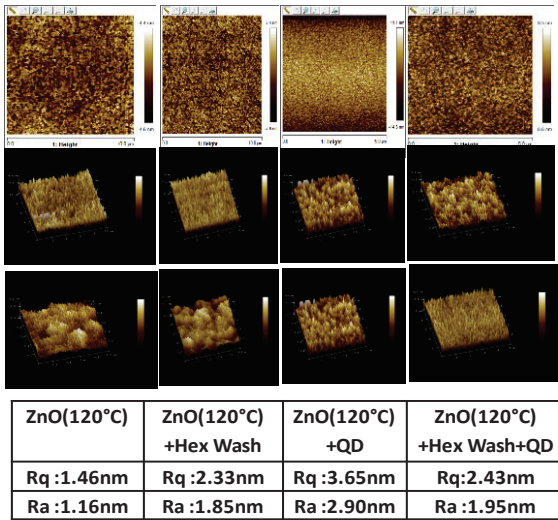


Figure. 5 AFM images of the ZnO-NP film annealed at 120 °C for 30 minutes (**Figure 5 A**), ZnO-NP-HW annealed at 120 °C for 30 minutes and then washed (treated) with hexane and then annealed at 80 °C for 30 minutes (**Figure 5B**), ZnO-NP + QD (**Figure 5 C**) and ZnO-NP (HW) +QD (**Figure 5 D**).

It was interesting to note that crystallinity of ZnO-NP and ZnO-NP-HW films were found to be 61% and 93% respectively (Thin Film XRD is shown in **Figure 6**). The increase in crystallinity is consistent with the increase in the roughness of ZnO-NP on washing with hexane.

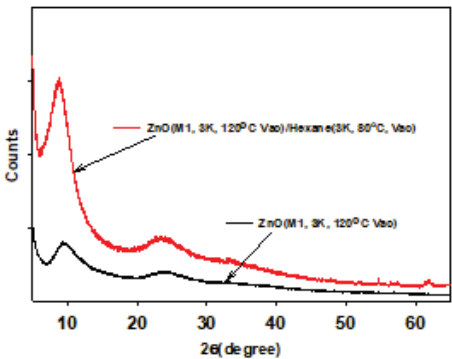


Figure 6: XRD of ZnO-NP (virgin) film and ZnO-NP-Hexane Wash (HW)

On treating the ZnO-NP with hexane (wash), the conduction and valence band are raised with respect to ZnO-NP-Virgin (see **Figure 7**) as determined from XPS/PES and from optical absorption edge (E_g). Further, we determined the mobility from the SCLC region of the electron only devices of (ITO/Al/ZnO-NP (virgin)/Al) and (ITO/Al/ZnO-NP-HW/Al) to be $3 \times 10^{-5} \text{ cm}^2 \text{ V}^{-1} \text{ s}^{-1}$ and $9 \times 10^{-5} \text{ cm}^2 \text{ V}^{-1} \text{ s}^{-1}$. The increase in mobility is also consistent with the increase in crystallinity.

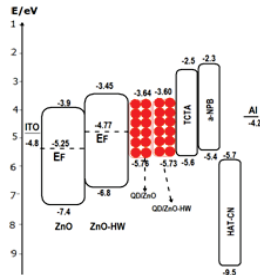


Figure 7. Energy level diagram of ZnO-NP (Virgin) and ZnO-NP-HW (Hexane washed/treated ZnO-NP)

3.1 Electroluminescent Devices Based on Red CdSe/ZnSe/ZnS.

Figure 8 illustrates the performance data for the devices

Type A ITO/ZnO (NP) (40 nm, Brunel) / Red-CdSe/ZnSe/ ZnS (25 nm) /TCTA (10 nm)/HTL (α-NPB or HTM-14)/ HATCN (10 nm)/Al and **Type B:** ITO/ZnO (NP)-HW (40 nm, Brunel) washed with hexane/ Red-CdSe/ZnSe/ZnS (25 nm) /TCTA (10 nm)/HTL (α-NPB or HTM-14)/HATCN (10 nm)/Al. The device performances are summarised in Table 1.

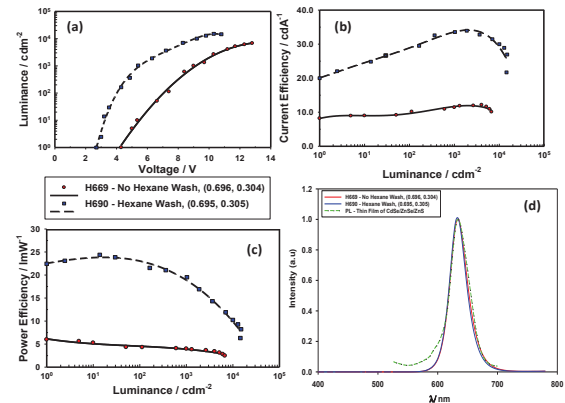


Figure 8 Device Performance of Type A and Type B (a). Luminance vs. Voltage, (b). Current Efficiency vs. Luminance., (c). Power Efficiency vs. Luminance., (d). Electroluminescence vs. photoluminescence spectra

Table 1. Device Performance for CdSe/ZnSe/ZnS devices. Type A and Type B.

Device I.D	Device Structure	CIE (x,y)	V_{t-on} /V(a)	V_d / V(b)	Current Efficiency / cdA^{-1} (b)	Power Efficiency / lmW^{-1} (b)	Max. Current Efficiency / cdA^{-1}	Max. Power Efficiency/ lmW^{-1}
Type A	ZnO-NP	(0.696, 0.303)	4.5	10.3	11.8	3.6	12.1	5.7
Type B	ZnO-NP –HW (Hexane Wash)	(0.695, 0.305)	2.8	5.5	32.6	18.6	32.6	23.4
Type B	ZnO-NP-HW, Thermal aging of the QLEDs at 40°C for 24 hours	(0.694, 0.306)	2.7	5.0	31.5	19.8	33.0	22.5
Type B	ZnO-NP-HW, Thermal aging of the QLEDs at 40°C for 120 hours	(0.693, 0.305)	2.3	4.4	30.7	21.9	35.2	35.1

(a). At 1 cdm^{-2} , (b). At 1000 cdm^{-2}

Table 2: Device Performance for red InP/ZnS devices. Type C, Type D and Type E

Device I.D	Device Structure	CIE (x,y)	V_{t-on} /V(a)	V_d / V(b)	Current Efficiency/ cdA^{-1} (b)	Power Efficiency / lmW^{-1} (b)	Max. Current Efficiency/ cdA^{-1}	Max. Power Efficiency/ lmW^{-1}
Type C	ZnO-NP/InP/ZnS cast from hexane	(0.672, 0.325)	2.4	3.4	2.5	2.4	3.6	4.7
Type D	ZnO-NP-HW /InP/ZnS cast from Octane	(0.683, 0.313)	2.2	3.7	0.8	0.5	1.0	0.8
Type E	ZnO-NP/InP/ZnS cast from Octane	(0.683, 0.313)	2.2	4.6	0.6	0.5	0.6	0.6

(a): At 1 cdm^{-2} , (b). At 100 cdm^{-2}

3.2 Electroluminescent Devices Based on Red InP/ZnS

Electroluminescent devices of Type C: ITO/ZnO (NP)(40 nm, Brunel)/Red-InP/ZnS (20 nm) cast from hexane/TCTA/HTL((α -NPB or HTM-14)/HAT-CN (10 nm)/Al, **Type D**: ITO/ZnO-NP-HW (40 nm, Brunel)/Red-InP/ZnS (20 nm) cast from Octane solution/TCTA/HTL((α -NPB or HTM-14)/HAT-CN (10 nm)/Al and **Type E**: ITO/ZnO-NP-HW (40 nm, Brunel)-Washed with hexane/Red-InP/ZnS (20 nm) cast from Octane solution/TCTA/HTL((α -NPB or HTM-14)/HAT-CN (10 nm)/Al are shown in Figure 9. The device performances are summarised in Table 2.

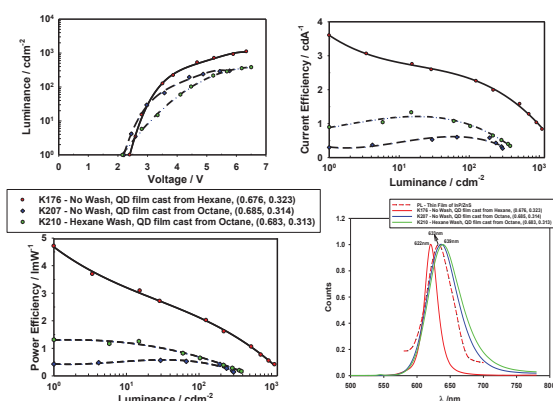


Figure 9. Comparison of InP/ZnS Device Performance: Type C, Type D and Type E

4 CONCLUSIONS

Using solvent based surface engineering of sol-gel derived ZnO-NP electron injector/electron transport layer, we achieved 2.76 fold increase in current efficiency to 32.6 cdA^{-1} and 5.17 fold increase in power efficiency to 18.6 lmW^{-1} at 1000 cdm^{-2} for Cd based QLEDs. We also report dark red electroluminescent InP/ZnS QDs ((x,y = 0.672, 0.325)) with a maximum current efficiency of 3.6 cdA^{-1} and 4.7 lmW^{-1} . We believe that the solvent based surface engineering has wide applicability and offers the scope for further improvement in QD –EL efficiency of InP/ZnS QD-EL.

Acknowledgement:

We thank Professors J. Buckingham, G. Rodgers and S. Dai for encouragement.

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